



# 5  
PATENT  
81877.0012

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:  
Seiyo NAKASHIMA et al.

Serial No: 09/816,643

Filed: March 23, 2001

For: SUBSTRATE PROCESSING  
APPARATUS AND SUBSTRATE  
PROCESSING METHOD

Art Unit: 1762

Examiner: Not assigned

I hereby certify that this correspondence  
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PETITION FOR EXTENSION OF TIME

Box Missing Parts  
Commissioner for Patents  
Washington, D.C. 20231

Dear Sir:

In accordance with 37 C.F.R. 1.136, Applicant respectfully petitions the  
Commissioner for a two-month extension of time extending to September 29, 2001,  
the period for response to the Notice to File Missing Parts dated May 29, 2001. A  
check for \$390.00 is enclosed. The responsive paper(s) are attached.

Please charge any insufficiency or credit any overpayment to Deposit Account  
No. 50-1314. A copy of this petition is enclosed.

Respectfully submitted,

HOGAN & HARTSON L.L.P.

By:

Lawrence J. McClure

Registration No. 44,228

Attorney for Applicant(s)

Date: September 28, 2001

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